



**PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q76993

Sadayuki OHNISHI

Appln. No.: 10/646,709

Confirmation No.: 9821

Group Art Unit: 2814

Filed: August 25, 2003

Examiner: Phat X. CAO

For: SEMICONDUCTOR DEVICE WITH INTERLAYER DIELECTRIC FILM AND  
MANUFACTURING METHOD THEREOF

**RESPONSE UNDER 37 C.F.R. § 1.114(c)**

**MAIL STOP RCE**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated February 8, 2007, time for responding to which  
being extended to June 8, 2007, please consider the remarks as submitted herewith on the  
accompanying pages.